

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

## Application of

Applicant

: Jigish D. Trivedi

Serial No.

: 08/915,658

Filed

: August 21, 1997

Title

: LOW RESISTANCE METAL SILICIDE LOCAL INTERCONNECTS AND

METHOD OF MAKING

Docket

: MIO 0024 PA

Examiner

: G. Peralta

Art Unit

: 2814

Assistant Commissioner for Patents

Washington, D.C. 20231

Sir:

## CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on October 31, 2000.

Reg. No. 29,001

## NOTICE OF APPEAL

Applicant hereby appeals from the final rejection of claims 31-34 in the Office Action mailed August 1, 2000. Our check in the amount of \$310.00 accompanies this Notice. 37 CFR §1.17(b).

Respectfully submitted,

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TWH/